

The documentation and process conversion measures necessary to comply with this revision shall be completed by 28 June 2012.

INCH-POUND

MIL-PRF-19500/664D
 28 March 2012
 SUPERSEDING
 MIL-PRF-19500/664C
 19 November 2007

PERFORMANCE SPECIFICATION SHEET

SEMICONDUCTOR DEVICE, FIELD EFFECT RADIATION HARDENED
 TRANSISTORS, N-CHANNEL, SILICON,
 TYPES 2N7431U, 2N7432U, AND 2N7433U,
 JANTXVR, F, G, AND H; AND JANSR, F, G, AND H

This specification is approved for use by all Departments and Agencies of the Department of Defense.

The requirements for acquiring the product described herein shall consist of this specification sheet and [MIL-PRF-19500](#).

1. SCOPE

* 1.1 Scope. This specification covers the performance requirements for an N-channel, enhancement-mode, MOSFET, radiation hardened, power transistor. Two levels of product assurance are provided for each device type specified in [MIL-PRF-19500](#), with avalanche energy maximum rating (E_{AS}) and maximum avalanche current (I_{AS}). See 6.5 for JANHC and JANKC die versions.

1.2 Physical dimensions. See [figure 1](#), SMD-2 (surface mount).

1.3 Maximum ratings. Unless otherwise specified, $T_C = +25^\circ\text{C}$.

| Type | P_T (1) | P_T $T_A = +25^\circ\text{C}$ (1) | $R_{\theta JC}$ (2) | V_{DS} | V_{DG} | V_{GS} | I_{D1} (3) (4) | I_{D2} $T_C = +100^\circ\text{C}$ (3) | I_S | I_{DM} (5) | T_J and T_{STG} |
|---------|--------------|---|------------------------|-------------|-------------|-------------|---------------------|---|-------------|-----------------|---------------------------|
| | <u>W</u> | <u>W</u> | <u>°C/W</u> | <u>V dc</u> | <u>V dc</u> | <u>V dc</u> | <u>A dc</u> | <u>A dc</u> | <u>A dc</u> | <u>A(pk)</u> | <u>°C</u> |
| 2N7431U | 300 | 2.5 | 0.42 | 60 | 60 | ±20 | 75.0 | 56.0 | 75.0 | 300 | -55 |
| 2N7432U | 300 | 2.5 | 0.42 | 100 | 100 | ±20 | 51.0 | 32.5 | 51.0 | 204 | to |
| 2N7433U | 300 | 2.5 | 0.42 | 200 | 200 | ±20 | 43.0 | 27.0 | 43.0 | 172 | +150 |

(1) Derate linearly by 2.4 W/°C for $T_C > +25^\circ\text{C}$.

(2) See [figure 2](#), thermal impedance curves.

(3) The following formula derives the maximum theoretical I_D limit. I_D is limited by package and internal construction.

$$I_D = \sqrt{\frac{T_{JM} - T_C}{(R_{\theta JC}) \times (R_{DS(on)} \text{ at } T_{JM})}}$$

(4) See [figure 3](#), maximum drain current graph.

(5) $I_{DM} = 4 \times I_{D1}$ as calculated in note (3).

* Comments, suggestions, or questions on this document should be addressed to DLA Land and Maritime, ATTN: VAC, P.O. Box 3990, Columbus, OH 43218-3990, or emailed to Semiconductor@dla.mil. Since contact information can change, you may want to verify the currency of this address information using the ASSIST Online database at <https://assist.dla.mil/>.

1.4 Primary electrical characteristics at $T_C = +25^\circ\text{C}$.

| Type | Min $V_{(BR)DSS}$ $V_{GS} = 0$ $I_D = 1.0$ mA dc | $V_{GS(TH)1}$ $V_{DS} \geq V_{GS}$ $I_D = 1.0$ mA dc | Max I_{DSS1} $V_{GS} = 0$ $V_{DS} = 80$ percent of rated V_{DS} | Max $r_{DS(ON)}$ (1) $V_{GS} = 12$ V dc | | E_{AS} at I_{D1} | I_{AS} | |
|---------|--|---|---|--|---|-------------------------|-----------|----------|
| | | | | $T_J = +25^\circ\text{C}$ at I_{D2} | $T_J = +150^\circ\text{C}$ at I_{D2} | | | |
| | <u>V dc</u> | <u>V dc</u> | | <u>$\mu\text{A dc}$</u> | <u>ohm</u> | <u>ohm</u> | <u>mJ</u> | <u>A</u> |
| | | Min | Max | | | | | |
| 2N7431U | 60 | 2.0 | 4.0 | 25 | 0.015 | 0.036 | 500 | 75.0 |
| 2N7432U | 100 | 2.0 | 4.0 | 25 | 0.040 | 0.100 | 500 | 51.0 |
| 2N7433U | 200 | 2.0 | 4.0 | 25 | 0.070 | 0.175 | 500 | 43.0 |

(1) Pulsed (see 4.5.1).

2. APPLICABLE DOCUMENTS

2.1 General. The documents listed in this section are specified in sections 3, 4, or 5 of this specification. This section does not include documents cited in other sections of this specification or recommended for additional information or as examples. While every effort has been made to ensure the completeness of this list, document users are cautioned that they must meet all specified requirements of documents cited in sections 3, 4, or 5 of this specification, whether or not they are listed.

2.2 Government documents.

2.2.1 Specifications, standards, and handbooks. The following specifications, standards, and handbooks form a part of this document to the extent specified herein. Unless otherwise specified, the issues of these documents are those cited in the solicitation or contract.

[MIL-PRF-19500](#) - Semiconductor Devices, General Specification for.

DEPARTMENT OF DEFENSE STANDARDS

[MIL-STD-750](#) - Test Methods for Semiconductor Devices.

* (Copies of these documents are available online at <https://assist.dla.mil/quicksearch/> or <https://assist.dla.mil/> or from the Standardization Document Order Desk, 700 Robbins Avenue, Building 4D, Philadelphia, PA 19111-5094.)

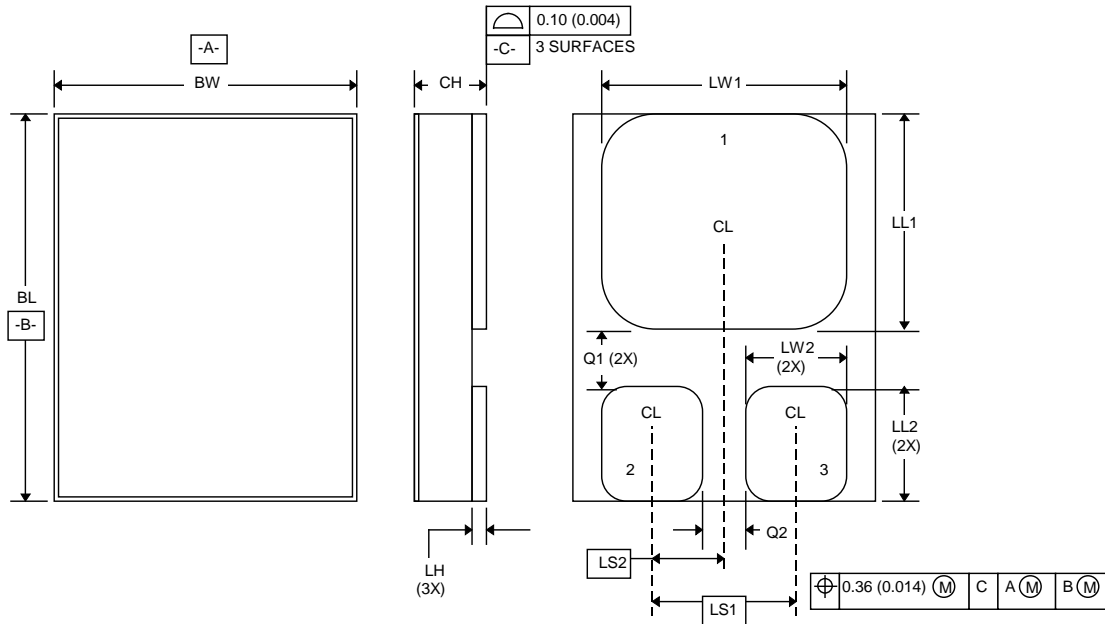
* 2.3 Order of precedence. Unless otherwise noted herein or in the contract, in the event of a conflict between the text of this document and the references cited herein, the text of this document takes precedence. Nothing in this document, however, supersedes applicable laws and regulations unless a specific exemption has been obtained.

3. REQUIREMENTS

3.1 General. The individual item requirements shall be as specified in [MIL-PRF-19500](#) and as modified herein.

3.2 Qualification. Devices furnished under this specification shall be products that are manufactured by a manufacturer authorized by the qualifying activity for listing on the applicable qualified manufacturer's list (QML) before contract award (see 4.2 and 6.3).

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| Symbol | Dimensions | | | |
|--------|------------|------|-------------|-------|
| | Inches | | Millimeters | |
| | Min | Max | Min | Max |
| BL | .685 | .695 | 17.40 | 17.65 |
| BW | .520 | .530 | 13.21 | 13.46 |
| CH | | .142 | | 3.60 |
| LH | .010 | .020 | 0.26 | 0.50 |
| LW1 | .435 | .445 | 11.05 | 11.30 |
| LW2 | .135 | .146 | 3.43 | 3.71 |
| LL1 | .470 | .480 | 11.94 | 12.19 |
| LL2 | .152 | .162 | 3.86 | 4.12 |
| LS1 | .240 BSC | | 6.10 BSC | |
| LS2 | .120 BSC | | 3.05 BSC | |
| Q1 | .035 | | 0.89 | |
| Q2 | .050 | | 1.27 | |
| Term 1 | Drain | | | |
| Term 2 | Gate | | | |
| Term 3 | Source | | | |

Notes:

1. Dimensions are in inches.
2. Millimeters are given for general information only.
3. The lid shall be electrically isolated from the drain, gate and source.
4. In accordance with ASME Y14.5M, diameters are equivalent to ϕ x symbology.

FIGURE 1. Physical dimensions for SMD-2 (surface mount package).

3.3 Abbreviations, symbols, and definitions. Abbreviations, symbols, and definitions used herein shall be as specified in [MIL-PRF-19500](#) and as follows:

I_{AS} Rated avalanche current, nonrepetitive
nC nano Coulomb.

3.4 Interface and physical dimensions. The interface and physical dimensions shall be as specified in [MIL-PRF-19500](#) and on [figure 1](#) herein. Methods used for electrical isolation of the terminals shall employ materials that contain a minimum of 90 percent Al_2O_3 (ceramic).

3.4.1 Terminal material and finish. Terminal material shall be copper-tungsten. Terminal finish shall be solderable as defined in [MIL-PRF-19500](#), [MIL-STD-750](#), and herein. Where a choice of terminal finish is desired, it shall be specified in the acquisition document (see [6.2](#)).

3.4.2 Internal construction. Multiple chip construction is not be permitted to meet the requirements of this specification.

3.5 Electrical performance characteristics. Unless otherwise specified herein, the electrical performance characteristics are as specified in paragraph [1.3](#), [1.4](#) and [table I](#).

3.6 Electrical test requirements. The electrical test requirements shall be as specified in [table I](#).

3.7 Electrostatic discharge protection. The devices covered by this specification require electrostatic discharge protection.

3.7.1 Handling. MOS devices must be handled with certain precautions to avoid damage due to the accumulation of static charge. However, the following handling practices are recommended.

- a. Devices should be handled on benches with conductive handling devices.
- b. Ground test equipment, tools, and personnel handling devices.
- c. Do not handle devices by the leads.
- d. Store devices in conductive foam or carriers.
- e. Avoid use of plastic, rubber, or silk in MOS areas.
- f. Maintain relative humidity above 50 percent if practical.
- g. Care should be exercised during test and troubleshooting to apply not more than maximum rated voltage to any lead.
- h. Gate must be terminated to source, $R \leq 100 \text{ k}\Omega$, whenever bias voltage is to be applied drain to source.

3.8 Marking. Marking shall be in accordance with [MIL-PRF-19500](#). At the option of the manufacturer, marking of the country of origin may be omitted from the body of the transistor but shall be retained on the initial container.

3.9 Workmanship. Semiconductor devices shall be processed in such a manner as to be uniform in quality and shall be free from other defects that will affect life, serviceability, or appearance.

4. VERIFICATION

4.1 Classification of inspections. The inspection requirements specified herein are classified as follows:

- a. Qualification inspection (see 4.2).
- b. Screening (see 4.3).
- c. Conformance inspection (see 4.4 and tables I and II).

4.2 Qualification inspection. Qualification inspection shall be in accordance with MIL-PRF-19500.

4.2.1 Group E qualification. Group E inspection shall be performed for qualification or re-qualification only. In case qualification was awarded to a prior revision of the specification sheet that did not request the performance of table III tests, the tests specified in table III herein that were not performed in the prior revision shall be performed on the first inspection lot of this revision to maintain qualification.

* 4.2.1.1 Single event effects (SEE). SEE shall be performed at initial qualification and after process or design changes which may affect radiation hardness (see table III and table IV). Upon qualification, manufacturers shall provide the verification test conditions from section 5 of method 1080 of MIL-STD-750 that were used to qualify the device for inclusion into section 6 of the slash sheet. End-point measurements shall be in accordance with table II. SEE characterization data shall be made available upon request of the qualifying or acquiring activity.

* 4.3 Screening (JANS and JANTXV levels only). Screening shall be in accordance with table E-IV of MIL-PRF-19500 and as specified herein. The following measurements shall be made in accordance with table I herein. Devices that exceed the limits of table I herein shall not be acceptable.

| Screen (see table E-IV of MIL-PRF-19500) (1) (2) | Measurement | |
|---|--|---|
| | JANS level | JANTXV levels |
| (3) | Gate stress test (see 4.3.1) | Gate stress test (see 4.3.1) |
| (3) | Method 3470 of MIL-STD-750, E _{AS} test (see 4.3.2) | Method 3470 of MIL-STD-750, E _{AS} test (see 4.3.2) |
| (3) 3c | Method 3161 of MIL-STD-750, thermal impedance (see 4.3.3) | Method 3161 of MIL-STD-750, thermal impedance (see 4.3.3) |
| 9 | Subgroup 2 of table I herein. I _{DSS1} , I _{GSSF1} , I _{GSSR1} . | Not applicable |
| 10 | Method 1042 of MIL-STD-750, test condition B | Method 1042 of MIL-STD-750, test condition B |
| 11 | I _{GSSF1} , I _{GSSR1} , I _{DSS1} , r _{DS(on)1} , V _{GS(TH)1} Subgroup 2 of table I herein. $\Delta I_{GSSF1} = \pm 20 \text{ nA dc or } \pm 100 \text{ percent of initial value, whichever is greater.}$ $\Delta I_{GSSR1} = \pm 20 \text{ nA dc or } \pm 100 \text{ percent of initial value, whichever is greater.}$ $\Delta I_{DSS1} = \pm 10 \text{ } \mu\text{A dc or } \pm 100 \text{ percent of initial value, whichever is greater.}$ | I _{GSSF1} , I _{GSSR1} , I _{DSS1} , r _{DS(on)1} , V _{GS(TH)1} Subgroup 2 of table I herein. |
| 12 | Method 1042 of MIL-STD-750, test condition A | Method 1042 of MIL-STD-750, test condition A |
| 13 | Subgroups 2 and 3 of table I herein. $\Delta I_{GSSF1} = \pm 20 \text{ nA dc or } \pm 100 \text{ percent of initial value, whichever is greater.}$ $\Delta I_{GSSR1} = \pm 20 \text{ nA dc or } \pm 100 \text{ percent of initial value, whichever is greater.}$ $\Delta I_{DSS1} = \pm 10 \text{ } \mu\text{A dc or } \pm 100 \text{ percent of initial value, whichever is greater.}$ $\Delta r_{DS(on)1} = \pm 20 \text{ percent of initial value}$ $\Delta V_{GS(th)1} = \pm 20 \text{ percent of initial value}$ | Subgroup 2 of table I herein. $\Delta I_{GSSF1} = \pm 20 \text{ nA dc or } \pm 100 \text{ percent of initial value, whichever is greater.}$ $\Delta I_{GSSR1} = \pm 20 \text{ nA dc or } \pm 100 \text{ percent of initial value, whichever is greater.}$ $\Delta I_{DSS1} = \pm 10 \text{ } \mu\text{A dc or } \pm 100 \text{ percent of initial value, whichever is greater.}$ $\Delta r_{DS(on)1} = \pm 20 \text{ percent of initial value}$ $\Delta V_{GS(th)1} = \pm 20 \text{ percent of initial value}$ |

- (1) At the end of the test program, I_{GSSF1}, I_{GSSR1}, and I_{DSS1} are measured.
- (2) An out-of-family program to characterize I_{GSSF1}, I_{GSSR1}, I_{DSS1} and V_{GS(th)1} shall be invoked.
- * (3) Shall be performed anytime after temperature cycling, screen 3a; JANTXV level does not need to be repeated in screening requirements.

4.3.1 Gate stress test. Apply $V_{GS} = 30$ V minimum for $t = 250$ μ s minimum.

4.3.2 Single pulse avalanche energy E_{AS} .

- a. Peak current (I_{AS}) $I_{AS} = I_{D1}$.
- b. Peak gate voltage (V_{GS})..... 12 V.
- c. Gate to source resistor (R_{GS}) $25\Omega \leq R_{GS} \leq 200\Omega$.
- d. Initial case temperature (T_C) $+25^\circ\text{C} +10^\circ\text{C}, -5^\circ\text{C}$.
- e. Inductance..... $\left[\frac{2E_{AS}}{(I_{D1})^2} \right] \left[\frac{V_{BR} - V_{DD}}{V_{BR}} \right]$ mH minimum
- f. Number of pulses to be applied..... 1 pulse minimum.
- g. Supply voltage (V_{DD}) 25 V (50 V for 2N7433).

4.3.3 Thermal impedance. The thermal impedance measurements shall be performed in accordance with method 3161 of [MIL-STD-750](#) using the guidelines in that method for determining I_M , I_H , t_H , t_{SW} , (and V_H where appropriate). Measurement delay time (t_{MD}) = 70 μ s max. See [table III](#), group E, subgroup 4 herein.

* 4.4 Conformance inspection. Conformance inspection shall be in accordance with [MIL-PRF-19500](#), and as specified herein.

4.4.1 Group A inspection. Group A inspection shall be conducted in accordance with table E-V of [MIL-PRF-19500](#) and [table I](#) herein. End-point electrical measurements shall be in accordance with [table I](#), subgroup 2 herein.

4.4.2 Group B inspection. Group B inspection shall be conducted in accordance with the conditions specified for subgroup testing in table E-VIA (JANS) and table E-VIB (JANTXV) of [MIL-PRF-19500](#), and herein. End-point electrical measurements shall be in accordance with [table I](#), subgroup 2 herein.

4.4.2.1 Group B inspection, table E-VIA (JANS) of [MIL-PRF-19500](#).

| <u>Subgroup</u> | <u>Method</u> | <u>Condition</u> |
|-----------------|---------------|---|
| B3 | 1051 | Test condition G, 100 cycles. |
| B3 | 2075 | See 3.4.2 . |
| B3 | 2077 | SEM qualification may be performed anytime prior to lot formation. |
| B4 | 1042 | Intermittent operation life, condition D, 2000 cycles . No heat sink or forced air cooling on the device shall be permitted during the on cycle; $t_{on} = 30$ seconds minimum. |
| B5 | 1042 | Accelerated steady-state gate bias, condition B, $V_{GS} = \text{rated}$, $T_A = +175^\circ\text{C}$, $t = 24$ hours minimum. |
| B5 | 1042 | Accelerated steady-state reverse bias, condition A, $V_{DS} = \text{rated}$, $T_A = +175^\circ\text{C}$, $t = 120$ hours minimum. |

4.4.2.2 Group B inspection, table E-VIB (JANTXV) of MIL-PRF-19500.

| <u>Subgroup</u> | <u>Method</u> | <u>Condition</u> |
|-----------------|---------------|---|
| B2 | 1051 | Test condition G, 25 cycles. |
| B3 | 1042 | Intermittent operation life, condition D, 2,000 cycles. No heat sink or forced air cooling on the device shall be permitted during the on cycle; $t_{on} = 30$ seconds minimum. |

4.4.3 Group C inspection. Group C inspection shall be conducted in accordance with the conditions specified for subgroup testing in table E-VII of MIL-PRF-19500 and as follows. Electrical measurements (end-points) and delta requirements shall be in accordance with the applicable tests of [table I](#), subgroup 2 herein.

| <u>Subgroup</u> | <u>Method</u> | <u>Condition</u> |
|-----------------|---------------|---|
| C2 | 2036 | Not applicable. |
| C5 | 3161 | Thermal resistance, see 4.3.3 , $R_{\theta JC(max)} = 0.42^{\circ}C/W$. |
| C6 | 1042 | Intermittent operation life, condition D, 6,000 cycles. No heat sink or forced air cooling on the device shall be permitted during the on cycle; $t_{on} = 30$ seconds minimum. |

4.4.4 Group D Inspection. Group D inspection shall be conducted in accordance with table E-VIII of MIL-PRF-19500 and [table II](#) herein.

4.4.5 Group E inspection. Group E inspection shall be conducted in accordance with the conditions specified for subgroup testing in table E-IX of MIL-PRF-19500 and as specified in [table III](#) herein. Electrical measurements (end-points) shall be in accordance with [table I](#), subgroup 2 herein.

4.5 Methods of inspection. Methods of inspection shall be as specified in the appropriate tables and as follows.

4.5.1 Pulse measurements. Conditions for pulse measurement shall be as specified in section 4 of MIL-STD-750.

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TABLE I. Group A inspection.

| Inspection <u>1/</u> | MIL-STD-750 | | Symbol | Limits | | Unit |
|--|-------------|---|-----------------|--------|-------|--------------------|
| | Method | Conditions | | Min | Max | |
| <u>Subgroup 1</u> | | | | | | |
| Visual and mechanical inspection | 2071 | | | | | |
| <u>Subgroup 2</u> | | | | | | |
| Thermal impedance <u>2/</u> | 3161 | See 4.3.3 | $Z_{\theta JC}$ | | | $^{\circ}C/W$ |
| Breakdown voltage, drain to source | 3407 | $V_{GS} = 0 V$; $I_D = 1 \text{ mA dc}$, bias condition C | $V_{(BR)DSS}$ | | | |
| 2N7431U | | | | 60 | | V dc |
| 2N7432U | | | | 100 | | V dc |
| 2N7433U | | | | 200 | | V dc |
| Gate to source voltage threshold | 3403 | $V_{DS} \geq V_{GS}$, $I_D = 1 \text{ mA dc}$ | $V_{GS(TH)1}$ | 2.0 | 4.0 | V dc |
| Gate current | 3411 | $V_{GS} = +20 \text{ V dc}$, $V_{DS} = 0$ | I_{GSSF1} | | + 100 | nA dc |
| Gate current | 3411 | $V_{GS} = -20 \text{ V dc}$, $V_{DS} = 0$ | I_{GSSR1} | | -100 | nA dc |
| Drain current | 3413 | $V_{GS} = 0 \text{ V dc}$, bias condition C, $V_{DS} = 80 \text{ percent of rated } V_{DS}$ | I_{DSS1} | | 25 | $\mu A \text{ dc}$ |
| Static drain to source on-state resistance | 3421 | $V_{GS} = 12 \text{ V dc}$, condition A, pulsed (see 4.5.1), $I_D = I_{D2}$ | $r_{DS(on)1}$ | | | |
| 2N7431U | | | | | 0.015 | ohm |
| 2N7432U | | | | | 0.040 | ohm |
| 2N7433U | | | | | 0.070 | ohm |
| Static drain to source on-state resistance | 3421 | $V_{GS} = 12 \text{ V dc}$, condition A pulsed (see 4.5.1), $I_D = I_{D1}$ | $r_{DS(on)2}$ | | | |
| 2N7431U | | | | | 0.018 | ohm |
| 2N7432U | | | | | 0.045 | ohm |
| 2N7433U | | | | | 0.077 | ohm |
| Forward voltage | 4011 | Pulsed (see 4.5.1), $I_D = I_{D1}$ $V_{GS} = 0 \text{ V dc}$ | V_{SD} | | | |
| 2N7431U | | | | | 1.5 | V dc |
| 2N7432U | | | | | 1.8 | V dc |
| 2N7433U | | | | | 1.8 | V dc |

See footnotes at end of table.

TABLE I. Group A inspection - Continued.

| Inspection 1/ | MIL-STD-750 | | Symbol | Limits | | Unit |
|--|-------------|---|---------------|---------------------|-------------------------|-------------------|
| | Method | Conditions | | Min | Max | |
| <u>Subgroup 3</u> | | | | | | |
| High temperature operation: | | $T_C = T_J = +125^\circ\text{C}$ | | | | |
| Gate current | 3411 | $V_{GS} = +20$ and -20 V dc, bias condition C, $V_{DS} = 0$ | I_{GSS2} | | ± 200 | nA dc |
| Drain current | 3413 | $V_{GS} = 0$ V; bias condition C, $V_{DS} = 80$ percent of rated V_{DS} | I_{DSS2} | | 0.25 | mA dc |
| Static drain to source on-state resistance | 3421 | $V_{GS} = 12$ V dc, pulsed (see 4.5.1), $I_D = I_{D2}$ | $r_{DS(on)3}$ | | | |
| 2N7431U 2N7432U 2N7433U | | | | | 0.030 0.085 0.140 | ohm ohm ohm |
| Gate to source voltage (threshold) | 3403 | $V_{DS} \geq V_{GS}$, $I_D = 1$ mA dc | $V_{GS(TH)2}$ | 1.0 | | V dc |
| Low temperature operation: | | $T_C = T_J = -55^\circ\text{C}$ | | | | |
| Gate to source voltage (threshold) | 3403 | $V_{DS} \geq V_{GS}$, $I_D = 1$ mA dc | $V_{GS(TH)3}$ | | 5.0 | V dc |
| <u>Subgroup 4</u> | | | | | | |
| Forward transconductance | 3475 | $I_D = \text{rated } I_{D2}$, $V_{DD} = 15$ V (see 4.5.1) | g_{FS} | | | |
| 2N7431U 2N7432U 2N7433U | | | | 18.0 16.0 9.0 | | S S S |
| Switching time test | 3472 | $I_D = I_{D1}$, $V_{GS} = 12$ V dc, $R_G = 2.35\Omega$, $V_{DD} = 50$ percent of rated V_{DS} | | | | |
| Turn-on delay time | | | $t_{d(on)}$ | | | |
| 2N7431U 2N7432U 2N7433U | | | | | 27 35 50 | ns ns ns |
| Rise time | | | t_r | | | |
| 2N7431U 2N7432U 2N7433U | | | | | 120 150 200 | ns ns ns |
| Turn-off delay time | | | $t_{d(off)}$ | | | |
| 2N7431U 2N7432U 2N7433U | | | | | 120 150 200 | ns ns ns |

See footnotes at end of table.

TABLE I. Group A inspection - Continued.

| Inspection <u>1/</u> | MIL-STD-750 | | Symbol | Limits | | Unit |
|--|-------------|---|-------------|--------|-------------------|----------------|
| | Method | Conditions | | Min | Max | |
| <u>Subgroup 4</u> - Continued | | | | | | |
| Fall time 2N7431U 2N7432U 2N7433U | | | t_f | | 100 130 130 | ns ns ns |
| <u>Subgroup 5</u> | | | | | | |
| Safe operating area test (high voltage) | 3474 | See figures 4, 5, and 6, $t_p = 10$ ms minimum, $V_{DS} = 80$ percent of maximum rated V_{DS} , ($V_{DS} \leq 200$) | | | | |
| Electrical measurements | | See table I, subgroup 2 | | | | |
| <u>Subgroup 6</u> | | | | | | |
| Not applicable | | | | | | |
| <u>Subgroup 7</u> | | | | | | |
| Gate charge | 3471 | Condition B | | | | |
| On-state gate charge 2N7431U 2N7432U 2N7433U | | | $Q_{g(on)}$ | | 270 310 290 | nC nC nC |
| Gate to source charge 2N7431U 2N7432U 2N7433U | | | Q_{gs} | | 60 53 42 | nC nC nC |
| Gate to drain charge 2N7431U 2N7432U 2N7433U | | | Q_{gd} | | 110 110 120 | nC nC nC |
| Reverse recovery time 2N7431U 2N7432U 2N7433U | 3473 | $di/dt \leq 100$ A/ μ s, $V_{DD} \leq 50$ V, $I_D = I_{D1}$ | t_{rr} | | 360 520 820 | ns ns ns |

1/ For sampling plan, see MIL-PRF-19500.

2/ This test required for the following end-point measurements only:
 Group B, subgroups 2 and 3 (JANTXV).
 Group B, subgroups 3 and 4 (JANS).
 Group C, subgroup 2 and 6.
 Group E, subgroup 1.

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TABLE II. Group D inspection.

| Inspection <u>1/ 2/ 3/</u> | MIL-STD-750 | | Symbol | Preirradiation limits | | | | Postirradiation limits | | | | Unit |
|--|-------------|--|----------|-----------------------|------|----------------------|------|------------------------|------|----------------------|------|-------|
| | Method | Conditions | | R | | F, G and H <u>5/</u> | | R | | F, G and H <u>5/</u> | | |
| | | | | Min | Max | Min | Max | Min | Max | Min | Max | |
| <u>Subgroup 1</u> | | | | | | | | | | | | |
| Not applicable | | | | | | | | | | | | |
| <u>Subgroup 2</u> | | TC = +25°C | | | | | | | | | | |
| Steady-state total dose irradiation (VGS bias) <u>4/</u> | 1019 | VGS = 12V, VDS = 0 | | | | | | | | | | |
| Steady-state total dose irradiation (VDS bias) <u>4/</u> | 1019 | VDS = 80 percent of rated VDS (pre-irradiation), VGS = 0 | | | | | | | | | | |
| Pre and post electricals: | | | | | | | | | | | | |
| Breakdown voltage, drain to source | 3407 | VGS = 0, ID = 1 mA, bias cond. C | VBRDSS | | | | | | | | | |
| 2N7431U | | | | 60 | | 60 | | 60 | | 60 | | V dc |
| 2N7432U | | | | 100 | | 100 | | 100 | | 100 | | V dc |
| 2N7433U | | | | 200 | | 200 | | 200 | | 200 | | V dc |
| Gate to source voltage (threshold) | 3403 | VDS ≥ VGS | VGS(th)1 | | | | | | | | | |
| 2N7431U | | | | 2.0 | 4.0 | 2.0 | 4.0 | 2.0 | 4.0 | 1.25 | 4.5 | V dc |
| 2N7432U | | | | 2.0 | 4.0 | 2.0 | 4.0 | 2.0 | 4.0 | 1.25 | 4.5 | V dc |
| 2N7433U | | | | 2.0 | 4.0 | 2.0 | 4.0 | 2.0 | 4.0 | 1.25 | 4.5 | V dc |
| Gate current | 3411 | VGS = 20 V, VDS = 0, bias cond. C | IGSSF1 | | 100 | | 100 | | 100 | | 100 | nA dc |
| Gate current | 3411 | VGS = -20 V, VDS = 0, bias cond. C | IGSSR1 | | -100 | | -100 | | -100 | | -100 | nA dc |
| Drain current | 3413 | VGS = 0, bias cond. C, VDS = 80 percent of rated VDS (pre-irradiation) | IDSS1 | | 25 | | 25 | | 25 | | 50 | μA dc |

See footnotes at end of table.

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TABLE II. Group D inspection - Continued.

| Inspection 1/ 2/ 3/ | MIL-STD-750 | | Symbol | Preirradiation limits | | | | Postirradiation limits | | | | Unit |
|--|-------------|---|----------------------|-----------------------|-------|---------------|-------|------------------------|-------|---------------|-------|------|
| | Method | Conditions | | R | | F, G and H 5/ | | R | | F, G and H 5/ | | |
| | | | | Min | Max | Min | Max | Min | Max | Min | Max | |
| Static drain to source on-state voltage 2N7431U 2N7432U 2N7433U | 3405 | V _{GS} = 12 V, cond. A, pulsed (see 4.5.1), I _D = I _{D2} | V _{DS(on)1} | | | | | | | | | |
| | | | | | 0.840 | | 0.840 | | 0.840 | | 1.400 | V dc |
| | | | | | 1.300 | | 1.300 | | 1.300 | | 1.852 | V dc |
| Forward voltage source to drain diode 2N7431U 2N7432U 2N7433U | 4011 | V _{GS} = 0, I _D = I _{D1} | V _{SD} | | | | | | | | | |
| | | | | | 1.5 | | 1.5 | | 1.5 | | 1.5 | V dc |
| | | | | | 1.8 | | 1.8 | | 1.8 | | 1.8 | V dc |
| | | | | | 1.8 | | 1.8 | | 1.8 | | 1.8 | V dc |

- 1/ For sampling plan, see MIL-PRF-19500.
- 2/ Group D qualification may be performed anytime prior to lot formation. Wafers qualified to these group D, QCI requirements may be used for any other specification utilizing the same die design.
- 3/ At the manufacturer's option, group D samples need not be subjected to the screening tests, and may be assembled in its qualified package or in any qualified package that the manufacturer has data to correlate the performance to the designated package.
- 4/ Separate samples shall be pulled for each bias.
- 5/ The "H" designation represents devices which pass end-points at the G, R, and F designated Total-Ionizing-Dose (TID).

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* TABLE III. Group E inspection (all quality levels) for qualification or re-qualification only.

| Inspection | MIL-STD-750 | | Sample plan |
|--|-------------|---|---------------------|
| | Method | Conditions | |
| <u>Subgroup 1</u> | | | 45 devices c = 0 |
| Temperature cycling | 1051 | Test condition G, 500 cycles. | |
| Hermetic seal | 1071 | | |
| Fine leak | | | |
| Gross leak | | | |
| Electrical measurements | | See table I , subgroup 2. | |
| <u>Subgroup 2 1/</u> | | | 45 devices c = 0 |
| Steady-state reverse bias | 1042 | Condition A, 1,000 hours. | |
| Electrical measurements | | See table I , subgroup 2. | |
| Steady-state gate bias | 1042 | Condition B, 1,000 hours. | |
| Electrical measurements | | See table I , subgroup 2. | |
| <u>Subgroup 4</u> | | | Sample size N/A |
| Thermal impedance curves | | See MIL-PRF-19500 . | |
| <u>Subgroup 10</u> | | | 22 devices c = 0 |
| Commutating diode for safe operating area test procedure for measuring dv/dt during reverse recovery of power MOSFET transistors or insulated gate bipolar transistors | 3476 | Test conditions shall be derived by the manufacturer | |
| <u>Subgroup 11</u> | | | 3 devices |
| SEE 2/ 3/ | 1080 | See MIL-STD-750 method 1080 and 6.2 . | |

[1/](#) A separate sample for each test shall be pulled.

* [2/](#) Group E qualification of SEE effect testing may be performed prior to lot formation. Qualification may be extended to other specification sheets utilizing the same structurally identical die design.

* [3/](#) Device qualification to a higher level LET is sufficient to qualify all lower level LETs.

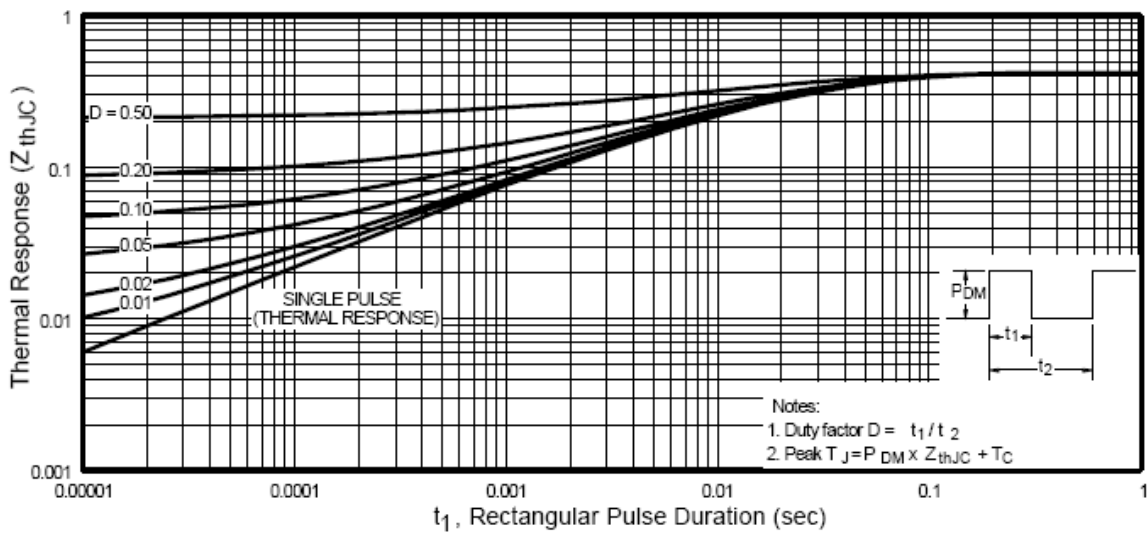
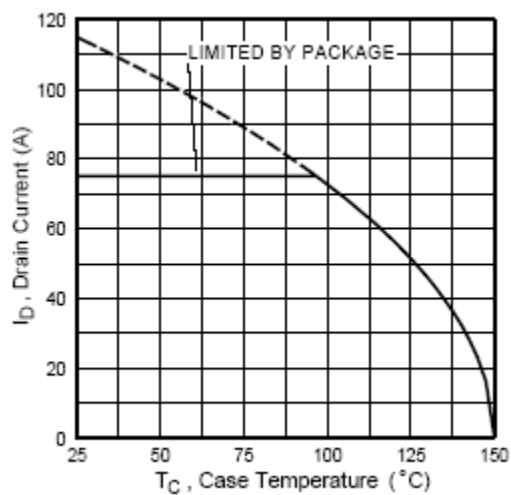
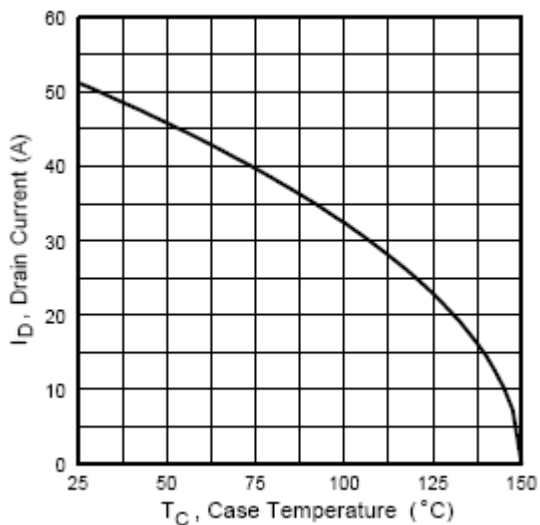


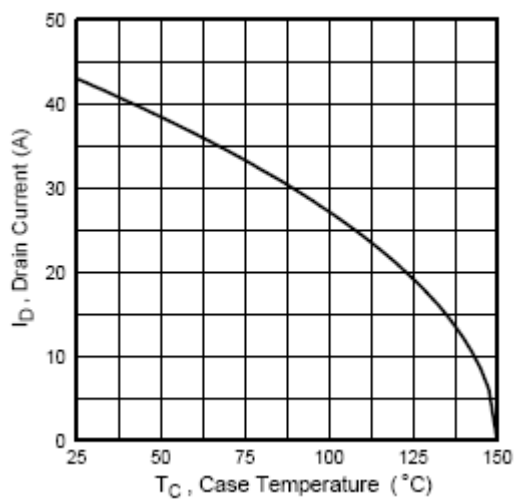
FIGURE 2. Thermal impedance curve.



2N7431U

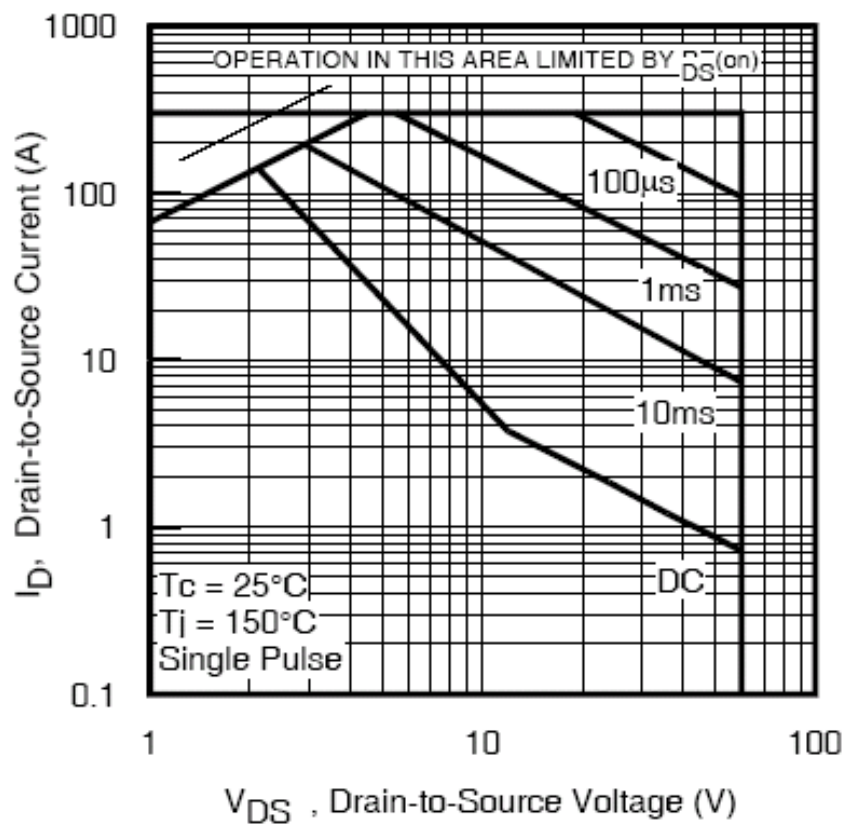


2N7432U

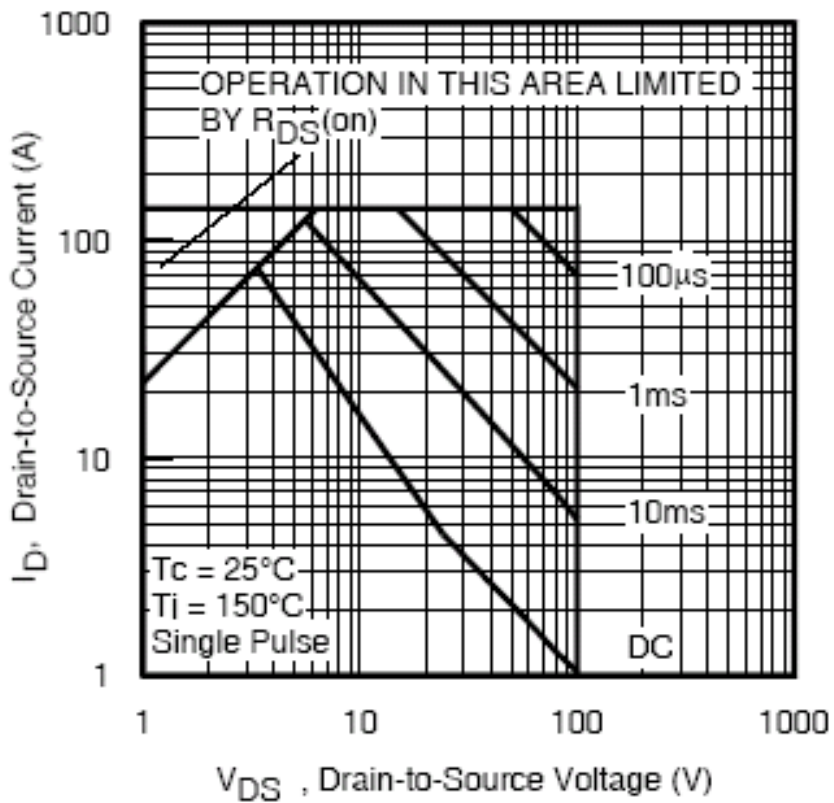


2N7433U

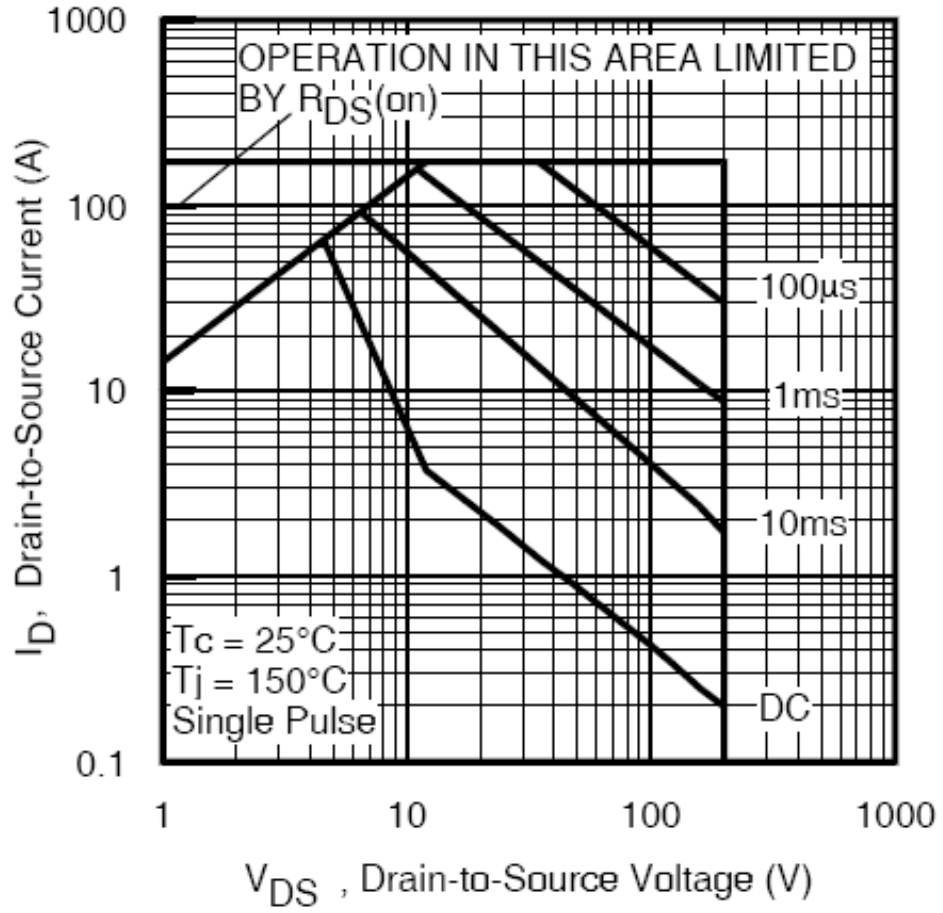
FIGURE 3. Maximum drain current vs case temperature graphs.



* FIGURE 4. Safe operating area graph for 2N7431U.



* FIGURE 5. Safe operating area graph for 2N7432U.



* FIGURE 6. Safe operating area graph for 2N7433U.

5. PACKAGING

5.1 Packaging. For acquisition purposes, the packaging requirements shall be as specified in the contract or order (see 6.2). When packaging of materiel is to be performed by DoD or in-house contractor personnel, these personnel need to contact the responsible packaging activity to ascertain packaging requirements. Packaging requirements are maintained by the Inventory Control Point's packaging activities within the Military Service or Defense Agency, or within the Military Service's system commands. Packaging data retrieval is available from the managing Military Department's or Defense Agency's automated packaging files, CD-ROM products, or by contacting the responsible packaging activity.

6. NOTES

(This section contains information of a general or explanatory nature that may be helpful, but is not mandatory. The notes specified in [MIL-PRF-19500](#) are applicable to this specification.)

6.1 Intended use. Semiconductors conforming to this specification are intended for original equipment design applications and logistic support of existing equipment.

* 6.2 Acquisition requirements. Acquisition documents should specify the following:

- a. Title, number, and date of this specification.
- b. Packaging requirements (see 5.1).
- c. Terminal material and finish (see 3.4.1).
- d. Product assurance level and type designator.
- * e. For acquisition of RHA designated devices, [table II](#), subgroup 1 testing of group D herein is optional. If subgroup 1 is desired, it should be specified in the contract.
- * f. If specific SEE characterization conditions are desired (see section 6.6 and [table IV](#)), manufacturer's cage code should be specified in the contract or order.
- * g. If SEE testing data is desired, it should be specified in the contract or order.

* 6.3 Qualification. With respect to products requiring qualification, awards will be made only for products which are, at the time of award of contract, qualified for inclusion in Qualified Manufacturers List (QML 19500) whether or not such products have actually been so listed by that date. The attention of the contractors is called to these requirements, and manufacturers are urged to arrange to have the products that they propose to offer to the Federal Government tested for qualification in order that they may be eligible to be awarded contracts or orders for the products covered by this specification. Information pertaining to qualification of products may be obtained from DLA Land and Maritime, ATTN: VQE, P.O. Box 3990, Columbus, OH 43218-3990 or e-mail vqe.chief@dla.mil. An online listing of products qualified to this specification may be found in the Qualified Products Database (QPD) at <https://assist.dla.mil>.

6.4 Substitution information. Devices covered by this specification are substitutable for the manufacturer's and user's Part or Identifying Number (PIN). This information in no way implies that manufacturer's PIN's are suitable for the military PIN.

| Preferred types Military PIN | Commercial PIN (1) |
|---------------------------------|-------------------------------------|
| 2N7431U 2N7432U 2N7433U | IRHNA_064 IRHNA_160 IRHNA_260 |

(1) IRHNA7: 100k RAD (Si)
 IRHNA3: 300k RAD (Si)
 IRHNA4: 600k RAD (Si)
 IRHNA8: 1000k RAD (Si)

6.5 JANC die versions. The JANHC and JANKC die versions of these devices are covered under specification sheet [MIL-PRF-19500/657](#).

* 6.6 Application data.

* 6.6.1 Manufacturer specific irradiation data. Each manufacturer qualified to this slash sheet has characterized its devices to the requirements of [MIL-STD-750](#) method 1080 and as specified herein. Since each manufacturer's characterization conditions can be different and can vary by the version of method 1080 qualified to, the [MIL-STD-750](#) method 1080 revision version date and conditions used by each manufacturer for characterization have been listed here (see [table IV](#)) for information only. SEE conditions and figures listed in section 6 are current as of the date of this specification sheet, please contact the manufacturer for the most recent conditions.

* TABLE IV. Manufacturers characterization conditions.

| Manufactures cage | Inspection | MIL-STD-750 | | Sample plan |
|--|--|-------------|--|-------------|
| | | Method | Conditions | |
| No manufacturers are currently qualified to the SEE requirements | SEE <u>1/</u> Electrical measurements | 1080 | See MIL-STD-750E method 1080 I_{GSSF1} , I_{GSSR1} , and I_{DSS1} in accordance with table I , subgroup 2 | 3 devices |
| | Electrical measurements | | I_{GSSF1} , I_{GSSR1} , and I_{DSS1} in accordance with table I , subgroup 2 | |
| <div style="border: 1px solid black; padding: 5px; width: fit-content; margin: 0 auto;"> Upon qualification, all manufacturers will provide the verification test conditions to be added to this table. </div> | | | | |

1/ I_{GSSF1} , I_{GSSR1} , and I_{DSS1} was examined before and following SEE irradiation to determine acceptability for each bias condition. Other test conditions in accordance with [table I](#), subgroup 2, may be performed at the manufacturer's option.

6.7 Changes from previous issue. The margins of this specification are marked with asterisks to indicate where changes from the previous issue were made. This was done as a convenience only and the Government assumes no liability whatsoever for any inaccuracies in these notations. Bidders and contractors are cautioned to evaluate the requirements of this document based on the entire content irrespective of the marginal notations and relationship to the last previous issue.

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